

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Chih-Chen Cho and
Zhongze Wang

Attorney Docket No.: 500982.02 (30016/US/2)

Filed : Concurrently herewith

Title : METHODS FOR MAKING SEMICONDUCTOR STRUCTURES HAVING HIGH-
SPEED AREAS AND HIGH-DENSITY AREAS

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

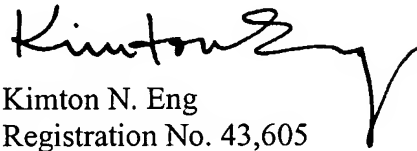
Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 09/945,077, filed August 30, 2001. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in this prior application and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,

DORSEY & WHITNEY LLP


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KNE:ajs
Enclosure:
Form PTO-1449

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FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
500982.02 (30016/US/2)APPLICATION NO.
Not Yet Assigned**INFORMATION DISCLOSURE STATEMENT***(Use several sheets if necessary)*

APPLICANT(S)

Chih-Chen Cho and Zhongze Wang

FILING DATE

Concurrently herewith

GROUP ART UNIT

Not Yet Assigned

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
|----------------------|----|-----------------|----------|------------------|-------|----------|-------------------------------|
| | AA | 5,899,742 | 05/04/99 | Sun | 438 | 682 | |
| | AB | 6,069,038 | 05/30/00 | Hashimoto et al. | 438 | 241 | |
| | AC | 6,083,828 | 07/04/00 | Lin et al. | 438 | 639 | |
| | AD | 6,274,409 B1 | 08/14/01 | Choi | 438 | 128 | |
| | AE | 6,300,178 B1 | 10/09/01 | Sunouchi | 438 | 199 | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|--|----|-----------------|------|---------|-------|----------|-------------|----|
| | | | | | | | YES | NO |
| | AK | | | | | | | |
| | AL | | | | | | | |
| | AM | | | | | | | |
| | AN | | | | | | | |
| | AO | | | | | | | |

OTHER PRIOR ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

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| | AP | |
| | AQ | |
| | AR | |

EXAMINER

DATE CONSIDERED

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).